



PATENT APPLICATION
IN THE U.S. PATENT AND TRADEMARK OFFICE

January 30, 2002

Applicant(s): Bruce M. WARNES, et al.

For: CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No.: 09/950 013 Group: 1762

Confirmation No.: 9221

Filed: September 10, 2001 Examiner: Unknown

Atty. Docket No.: MP-268B

Assistant Commissioner for Patents
Washington, DC 20231

RECEIVED
FEB 15 2002
TC 1700

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b) (3) and 1.98, enclosed herewith is Form PTO-1449 and the reference cited thereon. Accordingly, further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

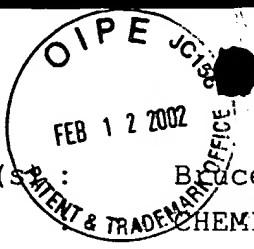
Respectfully submitted,

Edward J. Timmer

EJT/ad

Walnut Woods Centre
5955 W. Main St.
Kalamazoo, MI 49009
Tel: (616) 353-8807
Fax: (616) 372-3217

Encl: Form PTO-1449
One copy of each cited reference
Postal Card



4 1762
PATENT APPLICATION

Applicant (S): Bruce M. WARNES, et al.

Title CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No. : 09/950 013 Group: 1762

Confirmation No.: 9221

Filed : September 10, 2001 Examiner: Unknown

Atty. Docket No.: MP-268B

Assistant Commissioner for Patents
Washington, DC 20231

RECEIVED

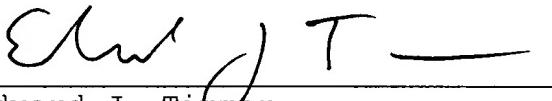
FEB 15 2002

TC 1700

FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington DC 20231, on January 30, 2002.


Edward J. Timmer

EJT/ad

Walnut Woods Centre
5955 W. Main St.
Kalamazoo, MI 49009
Tel: (616) 353-8807
Fax: (616) 372-3217

Correspondence: Information Disclosure Statement including enclosures listed thereon